



Application of

Applicants

: David L. Chapek

Serial No.

: 09/605,293

Filed

: June 28, 2000

Title

: SEMICONDUCTOR DEVICES INCLUDING A LAYER OF

POLYCRYSTALLINE SILICON HAVING A SMOOTH MORPHOLOGY

Docket

: MIO 0037 VA

Art Unit

: 2815

Examiner

: N.D. Richards

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents,

Washington, D.C. 20231, on April 10, 2003.

Assistant Commissioner for Patents

Washington, DC 20231

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby requests a one-month extension of time in which to respond to Final Rejection mailed December 16, 2002. Our check in the amount of \$110.00 accompanies this request.

Respectfully submitted,

KILLWORTH, GOTTMAN, HAGAN

& SCHAEFF, L.L.P.

By

Timothy W. Hagan

Registration No. 29,001

One Dayton Centre One South Main Street, Suite 500

Dayton, Ohio 45402-2023 Telephone: (937) 223-2050

Facsimile: (937) 223-0724

TWH/ems

04/16/2003 AWONDAF1 00000008 09605293

02 FC:1251

110.00 OP